

INFORMATION DISCLOSURE CITATION

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APPLICANT
Cha-Mei TangFILING DATE
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2876

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CEC	5 7 2 9 5 8 5	3/1998	Pellegrino et al.			
CEC	5 8 1 4 2 3 5	9/1998	Pellegrino et al.			
CEC	5 6 0 6 5 8 9	2/1997	Pellegrino et al.			
CEC	5 9 4 9 8 5 0	9/1999	Tang			
CEC	5 9 6 6 4 2 4	10/1999	Liu			
CEC	5 8 4 7 3 9 8	12/1998	Shahar et al.			
CEC	5 6 2 5 1 9 2	4/1997	Oda et al.			
CEC	5 5 7 6 1 4 7	11/1996	Guckel et al.			
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CEC	5 3 7 9 3 3 6	1/1995	Kramer et al.			
CEC	5 3 7 8 5 8 3	1/1995	Guckel et al.			
CEC	5 2 3 1 6 5 4	7/1993	Kwasnick et al.			
CEC	5 2 0 6 9 8 3	5/1993	Guckel et al.			
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OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

CEC	C.M. Tang, Small Business Information Research Solicitation No. DOE/ER-0686, 21 pages (March 1, 1997). ✓
CEC	C.M. Tang et al., "Anti-Scattering X-Ray Grid", <u>Microsystem Technologies</u> , pages 187-192 (1998). ✓
CEC	Larry E. Antonuk et al., "A Large-Area, 97 μ m Pitch, Indirect-Detection, Active Matrix, Flat-Panel Imager (AMFPI)", <u>Part of the SPIE Conference of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 2-13, (February 1998).</u> ✓
CEC	Radiological Society of North America, 80 th Scientific Assembly and Annual Meeting, November 27-December 2, 1994, page 253. ✓
CEC	Denny L. Lee et al., "Improved Imaging Performance of a 14 x 17-inch Direct Radiography TM System Using Se/TFT Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 14-23 (February 1998).</u> ✓
CEC	Robert Street et al., "Large Area X-Ray Image Sensing Using a PbI ₂ Photoconductor", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 24-32 (February 1998).</u> ✓

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CEC		5 2 6 3 0 7 5	11/1993	McGann et al.			
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CEC		Tom J.C. Bruijns et al., "Technical and Clinical Results of an Experimental Flat Dynamic (Digital) X-ray Image Detector (FDXD) System with Real-Time Corrections", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 33-44, (February 1998).</u>					
CEC		Christophe Chaussat et al., "New CsI/a-Si 17" x 17" X-Ray Flat Panel Detector Provides Superior Detectivity and Immediate Direct Digital Output for General Radiography Systems", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 45-56 (February 1998).</u>					
CEC		Hans Roehrig et al., "Flat-Panel Detector, CCD Cameras and Electron Beam Tube Based Video Camera for Use in Portal Imaging", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 163-174 (February 1998).</u>					
CEC		Herbert D. Zeman et al., "Portal Imaging with a CsI(Tl) Transparent Scintillator X-Ray Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 175-186 (February 1998).</u>					
CEC		Jean-Pierre Moy, "Image Quality of Scintillator Based X-ray Electronic Imagers", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 187-194 (February 1998).</u>					
CEC		G. Pang et al., "Electronic Portal Imaging Device (EPID) Based on a Novel Camera with Avalanche Multiplication", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 195-203 (February 1998).</u>					
CEC		Michael P. André et al., "An Integrated CMOS-Selenium X-Ray Detector for Digital Mammography", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 204-209 (February 1998).</u>					
CEC		Nicholas Petrick et al., "A Technique to Improve the Effective Fill Factor of Digital Mammographic Imagers", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 210-217 (February 1998).</u>					
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LEC		Richard E. Colbeth et al., "Flat Panel Imaging System for Fluoroscopy Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 376-387 (February 1998).</u>					
LEC		Akira Tsukamoto et al., "Development of a Selenium-Based Flat-Panel Detector for Real-Time Radiography and Fluoroscopy", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 388-395 (February 1998).</u>					
LEC		N. Jung et al., "Dynamic X-Ray Imaging System Based on an Amorphous Silicon Thin-Film Array", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 396-407 (February 1998).</u>					
LEC		Dylan C. Hunt et al., "Detective Quantum Efficiency of Direct, Flat Panel X-ray Imaging Detectors for Fluoroscopy", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 408-417 (February 1998).</u>					
LEC		Cornelis H. Slump et al., "Real-Time Diagnostic Imaging with a Novel X-ray Detector with Multiple Screen - CCD Sensors", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 418-429 (February 1998).</u>					
LEC		Edmund L. Baker et al., "A Physical Image Quality Evaluation of a CCD-Based X-ray Image Intensifier Digital Fluorography System for Cardiac Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 430-441 (February 1998).</u>					
LEC		Richard L. Weisfield et al., "New Amorphous-Silicon Image Sensor for X-Ray Diagnostic Medical Imaging Applications", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 444-452 (February 1998).</u>					
LEC		Toshio Kameshima et al., "Novel Large Area MIS-Type X-Ray Image Sensor for Digital Radiography", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 453-462 (February 1998).</u>					
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CEL		Gary S. Shaber et al., "Clinical Evaluation of a Full Field Digital Projection Radiography Detector", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 463-469 (February 1998).</u> ✓					
CEL		Donald R. Ouimette et al., "A New Large Area X-Ray Image Sensor", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, SPIE Vol. 3336, pages 470-476 (February 1998).</u> ✓					
CEL		David P. Trauernicht and John Yorkston, "Screen Design for Flat-Panel Imagers in Diagnostic Radiology", <u>Part of the SPIE Conference on Physics of Medical Imaging, San Diego, CA, pages 477-485 (February 1998).</u> ✓					
CEL		John Rowlands and Safa Kasap, "Amorphous Semiconductors Usher in Digital X-Ray Imaging", <u>Physics Today, pages 24-30 (November 1997).</u> ✓					
CEL		N.M. Allinson, "Development of Non-Intensified Charge-Coupled Device Area X-Ray Detectors", <u>Journal of Synchrotron Radiation, pages 54-62 (1994).</u> ✓					
CEL		I.M. Blevis et al., "Digital Radiology Using Amorphous Selenium and Active Matrix Flat Panel Readout: Photoconductive Gain and Gain Fluctuations", <u>Medical Imaging Research, Sunnybrook Science Center, University of Toronto, 8 pages.</u> ✓					
CEL		Justin M. Henry et al., "Noise in Hybrid Photodiode Array - CCD X-Ray Image Detectors for Digital Mammography", <u>SPIE Vol. 2708, pages 106-115 (February 1998).</u> ✓					
CEL		"DpiX' Digital X-Rays for Diagnosis and Treatment", <u>The Clock, pages 3, 5 and 19-21 (December '97/January '98).</u> ✓					
CEL		Russell C. Hardie et al., "Joint MAP Registration and High-Resolution Image Estimation Using a Sequence of Undersampled Images", <u>IEEE Transactions on Image Processing, Vol. 6 No.12, pages 1621-1632 (December 1997).</u> ✓					
EXAMINER <div style="text-align: center; font-size: 1.5em;">Chun</div>					DATE CONSIDERED 12/01		
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CEL	Joseph C. Gillette et al., "Aliasing Reduction in Staring Infrared Imagers Utilizing Subpixel Techniques", <u>Optical Engineering</u> , Vol. 34, No. 11, pages 3130-3137 (November 1995). ✓											
CEL	Russell C. Hardie et al., "High-Resolution Image Reconstruction from a Sequence of Rotated and Translated Frames and its Application to an Infrared Imaging System", <u>Optical Engineering</u> , Vol. 37, No. 1, pages 247-260, (January 1998). ✓											
CEL	Kai M. Hock, "Effect of Oversampling in Pixel Arrays", <u>Optical Engineering</u> , Vol. 34, No. 5, pages 1281-1288 (May 1995). ✓											
CEL	Kenneth J. Barnard et al. "Effects of Image Noise on Submicroscan Interpolation", <u>Optical Engineering</u> , Vol. 34, No. 11, pages 3165-3173 (November 1995). ✓											
CEL	Kenneth J. Barnard et al., "Nonmechanical Microscanning Using Optical Space-Fed Phased Arrays", <u>Optical Engineering</u> , Vol. 33, No. 9, pages 3063-3071 (September 1994). ✓											
CEL	Gerald C. Holst, <u>Sampling, Aliasing, and Data Fidelity</u> , pages 98-130 (published prior to Feb. 18, 1999). ✓											
CEL	Larry E. Antonuk et al., "Demonstration of Megavoltage and Diagnostic X-Ray Imaging with Hydrogenated Amorphous Silicon Arrays", <u>Am. Assoc. Phys. Med.</u> , Vol. 19, No. 6, pages 1455-1466 (Nov/Dec 1992). ✓											

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CEL		E.W. Becker et al., "Fabrication of Microstructures with high aspect ratios and great structural heights by synchrotron Radiation Lithography, Galvanoforming, and Plastic Molding (LIGA Process)," <u>Microelectronics Engineering</u> , Vol. 4 pages 35-56 (1986). ✓							
CEL		Dr. P. Bley, "The Liga Process for Fabrication of Three-Dimensional Microscale Structures," <u>Interdisciplinary Sci. Rev.</u> , Vol. 18, pages 267-272 (1993). ✓							
CEL		"DARPA Awards Contract for X-Ray Lithography System", <u>Micromachine Devices</u> , Vol. 2, No. 3, page 2 (1997).							
CEL		R.L. Egan, "Intramammary Calcifications Without an Associated Mass", <u>Radiology</u> , Vol. 137, pages 1-7 (1980). ✓							
CEL		H. Guckel, program and notes describing his "Invited talk at the American Vacuum Society Symposium", Philadelphia, PA, Oct. 1996. ✓							
CEL		"IBM Team Develops Ultrathick Negative Resist for MEMs Users", <u>Micromachine Devices</u> , Vol. 2, No. 3, page 1 (1997). ✓							
CEL		"X-Ray Lithography Scanners for LIGA", <u>Micromachine Devices</u> , Vol. 1, No. 2, page 8 (1996).							
CEL		E.P. Muntz et al., "On the Significance of Very Small Angle Scattered Radiation to Radiographic Imaging at Low Energies", <u>Med. Phys.</u> Vol. 10, pages 819-823 (1983). ✓							
CEL		M.J. Yaffe et al., "X-Ray Detectors for Digital Radiography", <u>Phys. Med. Biol.</u> , Vol. 42, pages 1-39 (1997). ✓							

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CEL		D.P. Siddons et al., "Precision Machining using Hard X-Rays", <u>Synchrotron Radiation News</u> , Vol. 7, No. 2, pages 16-18 (1994).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/liga.html", entitled "UW-MEMS-Research-Deep X-ray Lithography" (web site information available to public prior to June 19, 1987 filing date of present application).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/pc.html" entitled "UW-MEMS-Research-Precision Engineering" (web site information available to public prior to June 19, 1987 filing date of present application).					
CEL		Computer printout of University of Wisconsin Web Site "http://mems.engr.wisc.edu/~guckel/homepage.html" (web site information available to public prior to June 19, 1987 filing date of present application).					
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CEL	H. Guckel et al., "Micromechanics via x-ray assisted processing", <u>Journal of Vacuum Science Technology</u> , pages 2559-2564 (July/August 1994).
CEL	W. Ehrfeld, "Coming to Terms with the Past and the Future", <u>LIGA News</u> , pages 1-3 (January 1995).
CEL	H. Guckel et al., "Micro Electromagnetic Actuators Based on Deep X-Ray Lithography", <u>MIMR '95, Sendai, Japan</u> , (September 27-29, 1995).
CEL	H. Guckel et al., "Micromechanics for actuators via deep x-ray lithography", <u>Proceedings of SPIE, Orlando, Florida</u> , pages 39-47 (April 1994).
CEL	Z. Jing et al., "Imaging characteristics of plastic scintillating fiber screens for mammography", <u>SPIE</u> , Vol. 2708, pages 633-644 (February 1996).
CEL	N. Nakamori et al., "Computer simulation on scatter removing characteristics by grid", <u>SPIE</u> Vol. 2708, pages 617-625 (February 1996).
CEL	P. A. Tompkins et al., "Use of capillary optics as a beam intensifier for a Compton x-ray source", <u>Medical Physics</u> , Vol. 21, No. 11, pages 1777-1784 (November 1994).

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CEL	R. Fahrig et al., "Performance of Glass Fiber Antiscatter Devices at Mammographic Energies", <u>Am. Assoc. Phys. Med.</u> , Vol, 21, No. 8, pages 1277-1282 (August 1994).
CEL	L.E. Antonuk et al., "Large Area, Flat-Panel, Amorphous Silicon Imagers", <u>SPIE</u> Vol. 2432, pages 216-227 (July 1995).
CEL	H.E. Johns, OC, Ph.D., F.R.S.C., LL.D., D.Sc., F.C.C.P.M., <u>The Physics of Radiology</u> , Fourth Edition (Charles C. Thomas: Springfield, Illinois, 1983), page 734.
CEL	Collimated Holes, Inc. Products Manual, pages entitled "Rectangular and Square Fibers/Fiber Arrays" (April 1995) and "Scintillating Fiberoptic Faceplate Price List Type LKH-6" (December 1995).
CEL	H. Guckel et al., "LIGA and LIGA-Like Processing with High Energy Photons", <u>Microsystems Technologies</u> , Vol. 2, No. 3, pages 153-156 (August 1996).
CEL	H. Guckel et al., "Deep X-Ray Lithography for Micromechanics and Precision Engineering", <u>Synchrotron Radiation Instrumentation (Invited)</u> , Advanced Photon Source Argonne, pages 1-8 (October 1995).

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